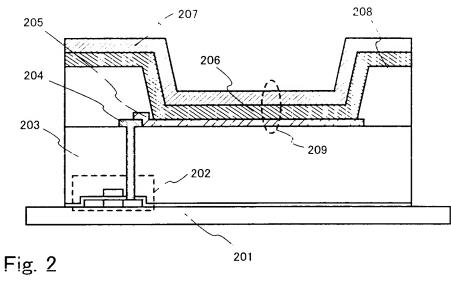
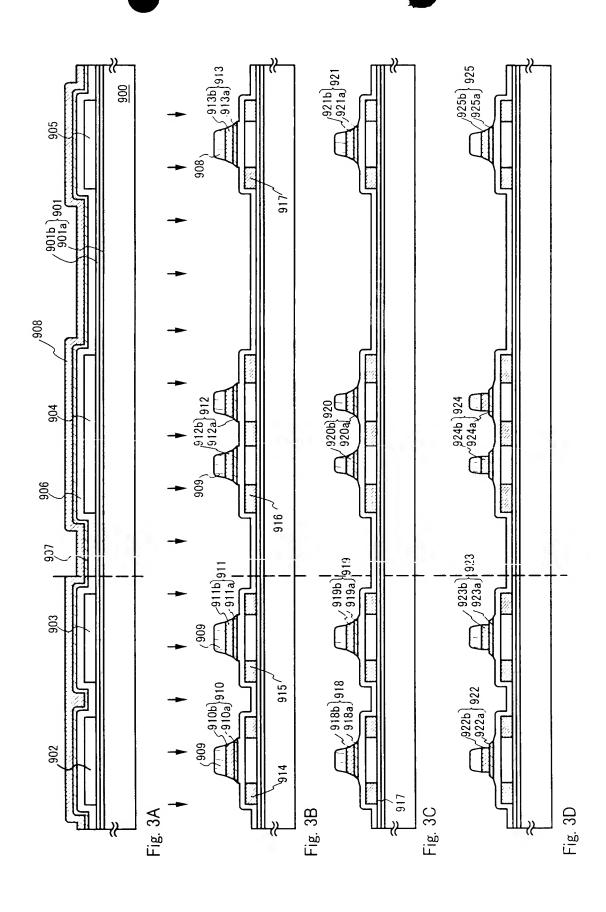
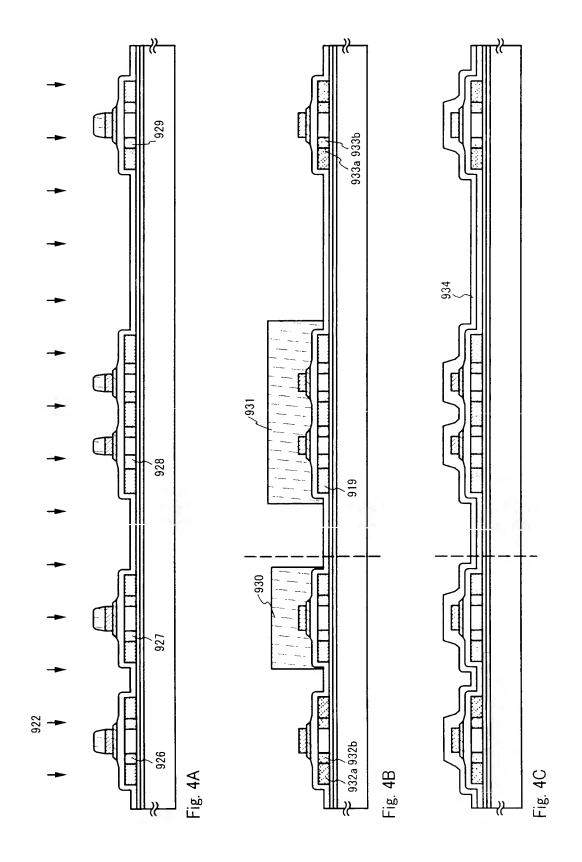


Fig. 1E







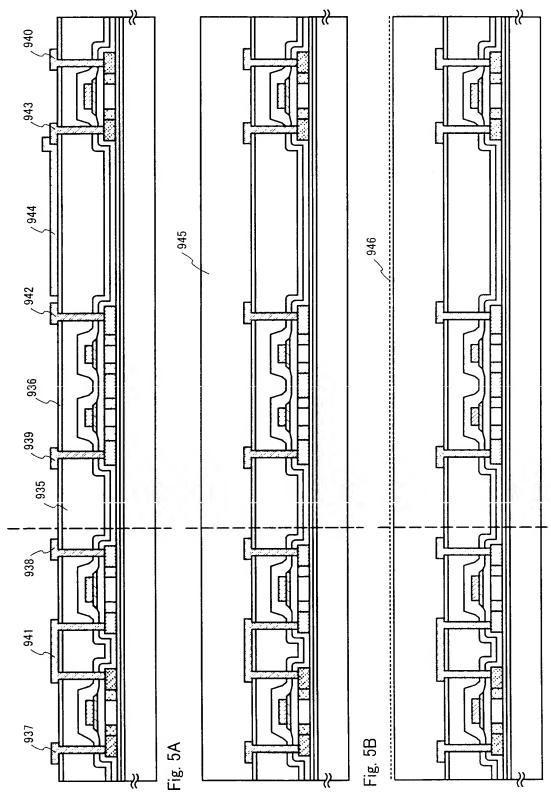


Fig. 5C

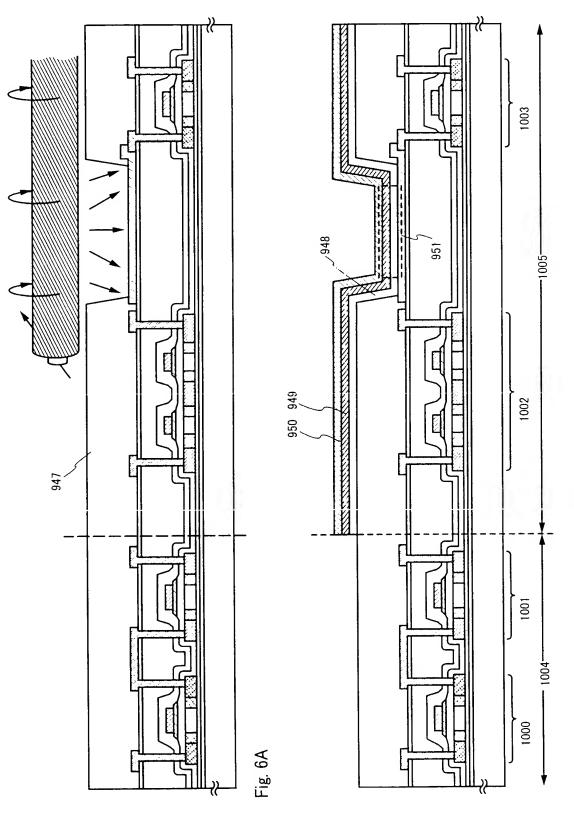


Fig. 6B

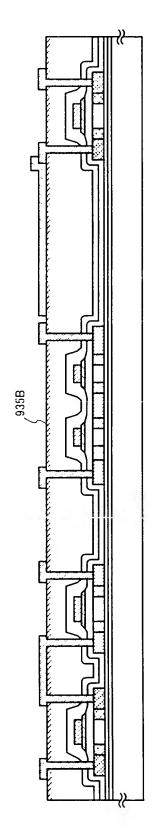


Fig. 7

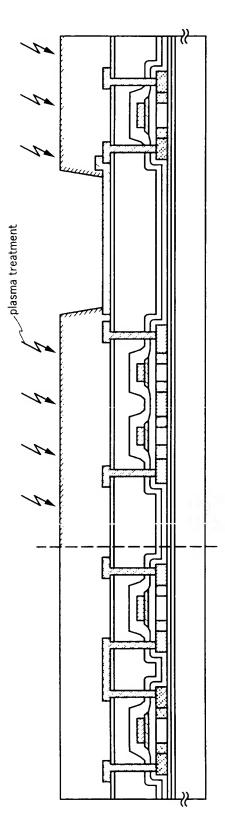
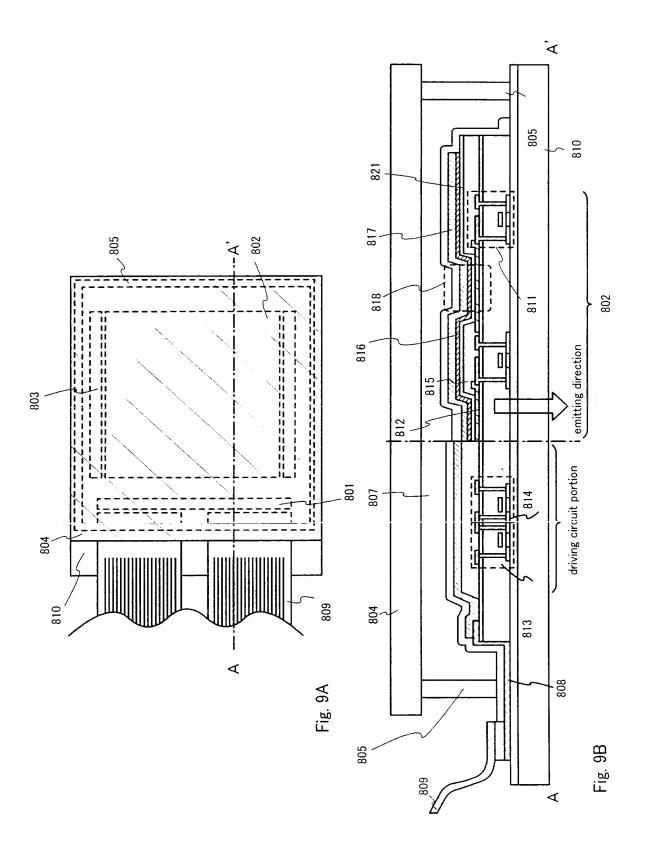


Fig. 8



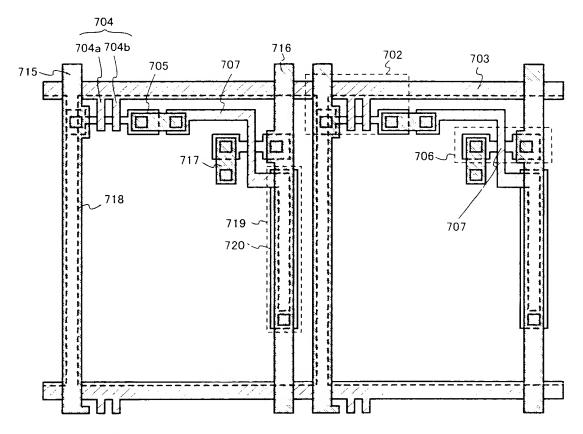


Fig. 10A

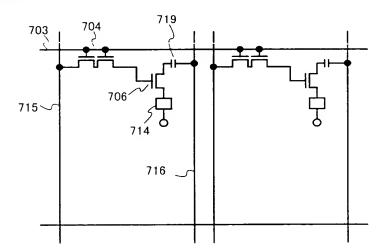
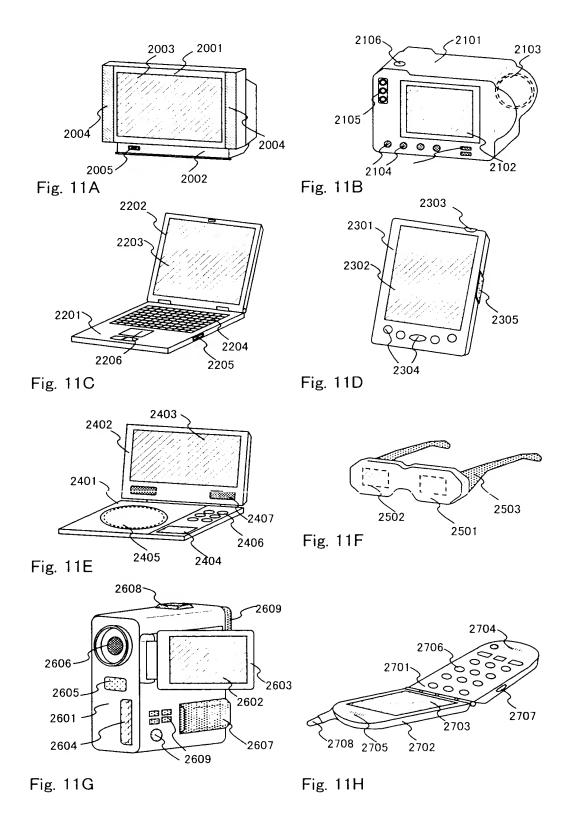


Fig. 10B



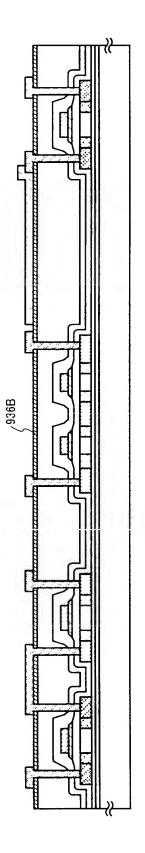


Fig. 12

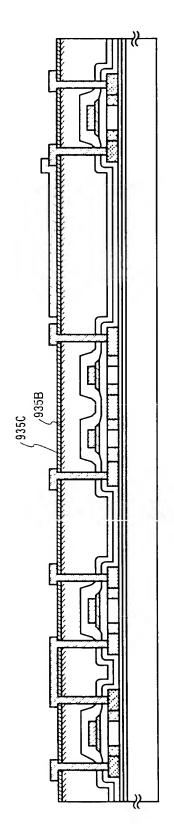
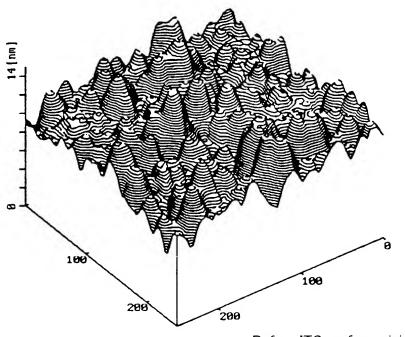


Fig. 13



Before ITO surface wiping

Fig. 14

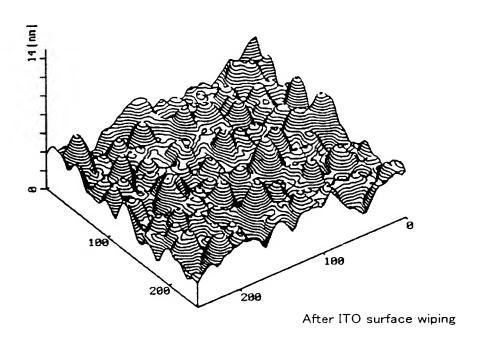


Fig. 15

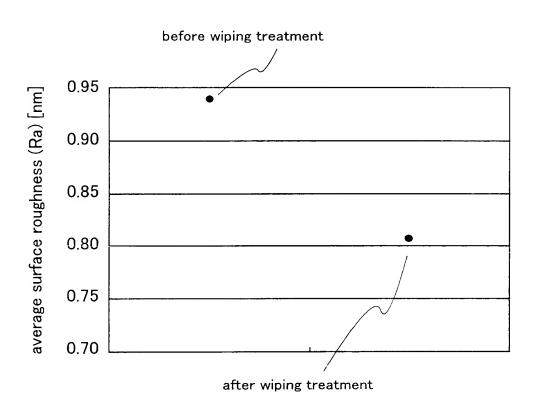
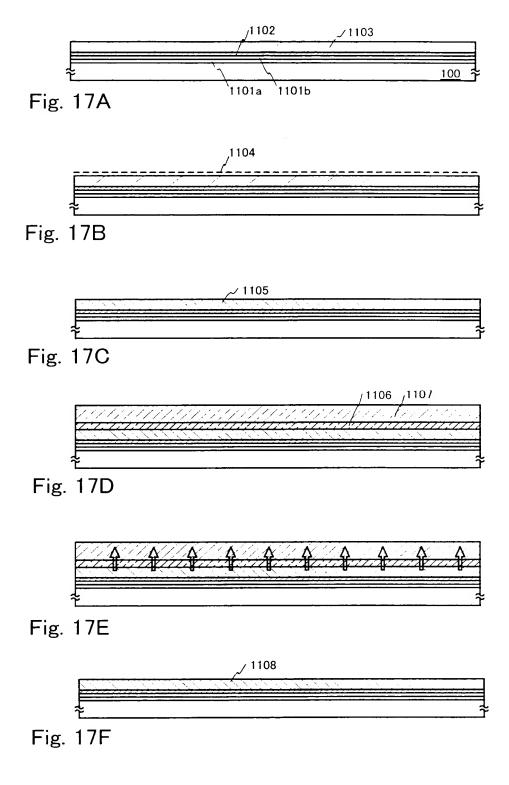


Fig. 16



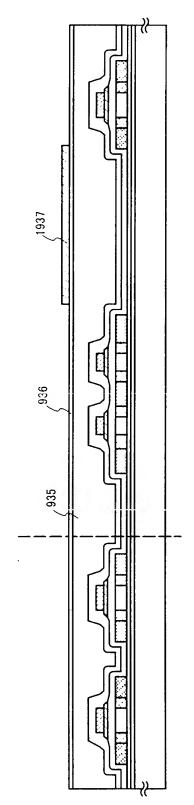


Fig. 18A

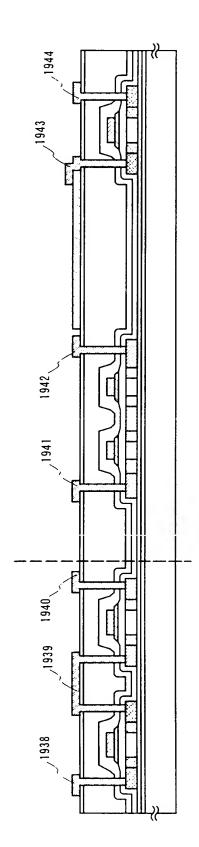
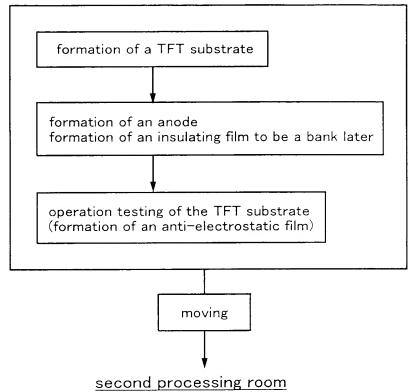


Fig. 18B

## a first processing room



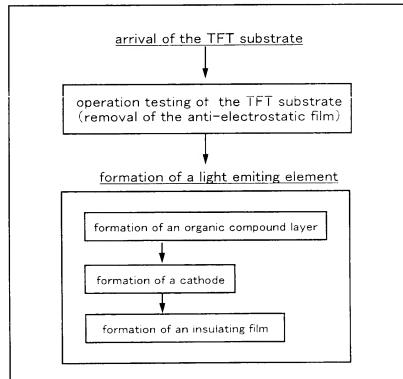


Fig. 19

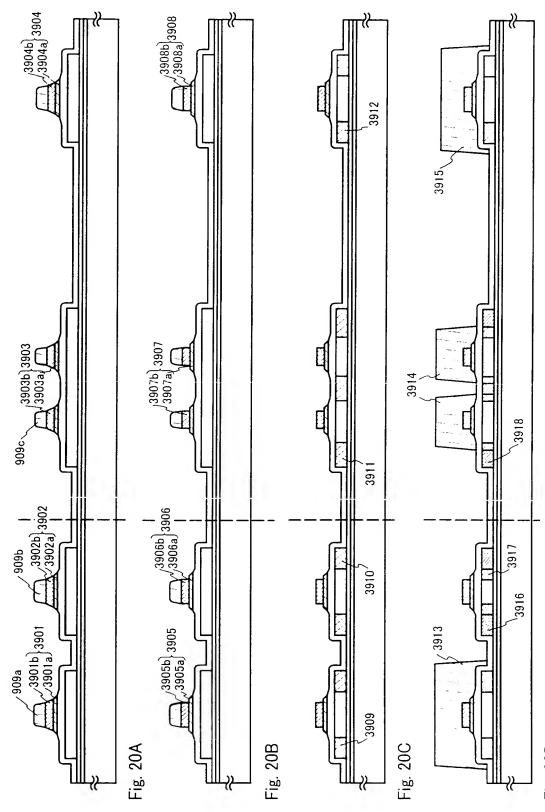


Fig. 20D

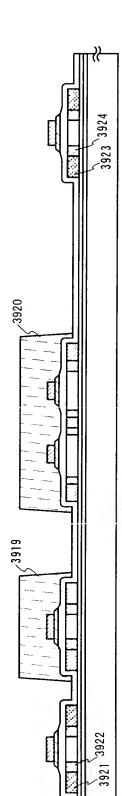


Fig. 21A

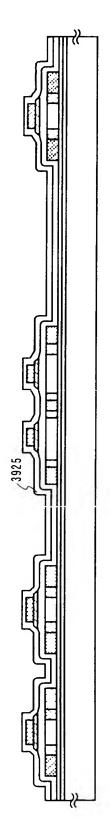


Fig. 21B

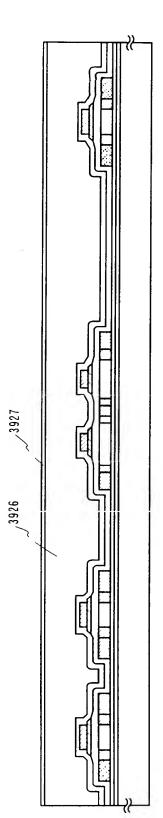


Fig. 21C

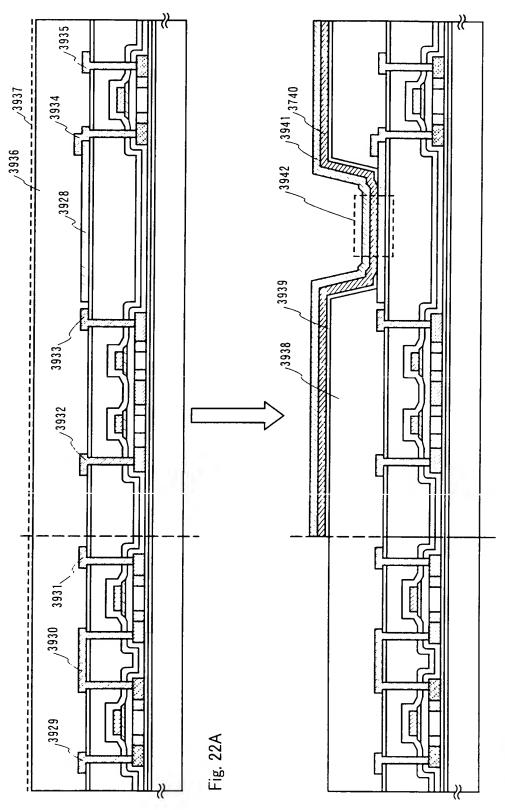


Fig. 22B

